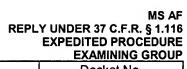
Hoza





AMENDMENT TRANSMITTAL LETTER						Docket No. 3430-0175P	
Application No. 10/028,433-Conf. #4398		Filing Date December 28, 2001		Examiner T. V. Duong		Art Unit 2871	
Applicant(s): Young-Sang BYUN et al.							
Invention: METHOD OF FORMING A LIQUID CRYSTAL LAYER USING INK JET SYSTEM							
MS AF Commissioner for P.O. Box 1450 Alexandria, VA 223 Transmitted here	313-1450 with is an ame			• •			
The fee has been calculated and is transmitted as shown below.							
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate			
Total Claims	20	- 20 =	0	x 50.00		0.00	
Independent Claims	2	- 3 =	0	x 200.00		0.00	
Multiple Dependent Claims (check if applicable)  Other fee (please specify):							
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:						0.00	
X   Large Entity   Small Entity   X   No additional fee is required for this amendment.							
BIRCH, STEW, 8110 Gatehous Suite 100 East P.O. Box 747 Falls Church, V (703) 205-8000	e Road irginia 22040-		LP				



Docket No.: 3430-0175P

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Young-Sang BYUN et al.

Application No.: 10/028,433

Confirmation No.: 4398

Filed: December 28, 2001

Art Unit: 2871

For: METHOD OF FORMING A LIQUID

CRYSTAL LAYER USING INK JET SYSTEM

Examiner: T. V. Duong

## AMENDMENT IN REPOSNE TO FINAL OFFICE ACTION

MS AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **INTRODUCTORY COMMENTS**

In response to the Examiner's final Office Action dated March 12, 2007, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

Amendments to the Claims; and

Remarks.